

Mask

SUPPLIER	MODEL	DESCRIPTION	IN STOCK	MAY BE ABLE TO SOURCE	EXPECT SOON	WAFER SIZE
CARL ZEISS	AIMSfab-193	AERIAL IMAGE MEASUREMENT SYSTEM	X			N/A
CARL ZEISS	AIMS-32	193nm IMMERSION METROLOGY REPAIR	X			N/A

200mm

SUPPLIER	MODEL	DESCRIPTION	IN STOCK	MAY BE ABLE TO SOURCE	EXPECT SOON	WAFER SIZE
APPLIED MATERIALS / AMAT	5200 CENTURA	RTP BPSG/LD/ANNEAL/SD	X			200mm
APPLIED MATERIALS / AMAT	5200 CENTURA	RTP GATE-TOXIC	X			200mm
APPLIED MATERIALS / AMAT	5200 CENTURA	RTP SAL-NON TOXIC	X			200mm
APPLIED MATERIALS / AMAT	5200 ULTIMA	HDP ILD1 TO N, CU			X	200mm
APPLIED MATERIALS / AMAT	5500 ENDURA	CU BARRIER/SEED (SIP CHAMBERS)			X	200mm
APPLIED MATERIALS / AMAT	MIRRA MESA	POLISHER, CU			X	200mm
APPLIED MATERIALS / AMAT	MIRRA TRAK	CMP/SCRUBBER-STI			X	200mm
APPLIED MATERIALS / AMAT	SEM VISION CX	AUTO DEFECT REVIEW SEM/EDX	X			200mm
APPLIED MATERIALS / AMAT	XR80	LOW ENERGY IMPLANTER - LEAP I	X			200mm
BROOKS AUTOMATION INC	100-0146	AUTO RETICLE MACRO INSPECTION	X			200mm
HITACHI HTA	8820	CD SEM 8820	X			200mm
HITACHI HTA	M712E	SHALLOW TRENCH ETCHER	X			200mm
HITACHI HTA	S8840	CD SEM S8840	X			200mm
KLA TENCOR CORPORATION	2135	DEFECT INSPECTION	X			200mm
KLA TENCOR CORPORATION	2139	BRIGHTFIELD PATTERN			X	200mm
KLA TENCOR CORPORATION	5240	PARC OPTIPROBE	X			200mm
KLA TENCOR CORPORATION	AIT2	DARK FIELD INSPECTION SYSTEM	X			200mm
KLA TENCOR CORPORATION	AIT UV+	FUSION UV+ DARKFIELD	X			200mm
KLA TENCOR CORPORATION	AIT-XP PLUS	PATTERNED WAFER INSPECTION, DARKFIELD	X			200mm
KLA TENCOR CORPORATION	QUANTOX 64100	GATE OXIDE SURFACE CHARGE	X			200mm
LAM RESEARCH CORPORATION / LRC	200 SERIES 2	DSS OXIDE/ILS			X	200mm
LAM RESEARCH CORPORATION / LRC	200 SERIES 2	DSS-W, CU			X	200mm
METRON TECHNOLOGY	ECLIPSE	TI/NIV SPUTTER (C4)	X			200mm
NIKON PRECISION INC	AM-601D	RETICLE INSPECTION	X			N/A
NIKON PRECISION INC	BODY 12	STEPPER I-LINE	X			200mm
NIKON PRECISION INC	BODY 9	STEPPER I-LINE	X			200mm
NIKON PRECISION INC	S204	248nm (0.68NA) SCANNER	X			200mm
NOVELLUS SYSTEMS INC	SABRE-XT	CU ELECTROPLATER AUTO	X			200mm
RUDOLPH TECHNOLOGIES	METAPULSE 200	ADHESION THICKNESS	X			200mm
SCP / AKRION	9415	BACK END (CU)	X			200mm
SCP / AKRION	9415	TW #2 LITHO/TF-CU REGEN	X			200mm
SEMITOOL	WST 308	SST C4	X			200mm
SEMITOOL	WST 308	SST PI REAR EXHAUST	X			200mm
SUSS MICROTECH	MA200	MASK ALIGNER, C4	X			200mm
TOKYO ELECTRON LTD / TEL	ACT 8	SPIN ON GLASS STAND ALONE TRACK	X			200mm
VARIAN	E1000	IMPLANTER	X			200mm
VARIAN	KESTREL 750	MEV IMPLANTER	X			200mm

300mm

SUPPLIER	MODEL	DESCRIPTION	IN STOCK	MAY BE ABLE TO SOURCE	EXPECT SOON	WAFER SIZE
APPLIED MATERIALS / AMAT	5500 ENDURA	CU BARRIER/SEED (300/CLASSIC)		X		300mm
APPLIED MATERIALS / AMAT	5500 ENDURA	C4 SPUTTER - 1DG, 1PCXT, 1Ti, 1Cu (300/Classic)	X			300mm
APPLIED MATERIALS / AMAT	CENTURA	RTP, TOXIC, A LEVEL 2 CHMBR	X			300mm
APPLIED MATERIALS / AMAT	CENTURA	RTP,NON TOXIC,B LEVEL SOAK 2CH	X			300mm
APPLIED MATERIALS / AMAT	EMT001	IMPLANT ELECTRODE METROLOGY	X			300mm
APPLIED MATERIALS / AMAT	NEW AERA	RETICLE INSPECTION		X		300mm
APPLIED MATERIALS / AMAT	P3I	IMPLANTER		X		300mm
APPLIED MATERIALS / AMAT	QUANTUM X	SINGLE WAFER HIM		X		300mm
APPLIED MATERIALS / AMAT	QUANTUM X+	SINGLE WAFER HIGH CURRENT IMPLANTER	X			300mm
APPLIED MATERIALS / AMAT	REFELXIONS	POLISHER, CU (MESA CLEANER)		X		300mm
APPLIED MATERIALS / AMAT	ULTIMA X	DEPOSITION (4.0)		X		300mm
ASM AMERICA INC	A412	DUAL REACTOR VDF CURE, CU, PI	X			300mm
ASM AMERICA INC	EAGLE 12	VLK ILD DEPOSITION, CU	X			300mm
ASM AMERICA INC	EPSILON E3200	EPI TOOL (RP OPTION)	X			300mm
ASML	XT1250	193NM SCANNER (.85 NA)	X			300mm
AXCELIS TECHNOLOGIES INC	PS3	DUV CURE, DUAL CHAMBER	X			300mm
CAMECA	SHALLOW PROBE	EPI DOPANT CONCENT	X			300mm
CHECKPOINT TECHNOLOGIES	INFRASCAN 200 I	LASER ASSISTED DEVICE ALTERATION	X			300mm
DISCO	DAD3350	WAFER SAW		X		300mm
DISCO	DAG810	GRINDER		X		300mm
DNS	FC-3000	WET STATION		X		300mm
DNS	SU3800			X		300mm
DTL TECH	CB 2004-300	WAFER ELUTER	X			300mm
EBARA TECHNOLOGIES INC	UFP-300A	AUTO PLATER	X			300mm
FEI	STRATA 235	DUAL BEAM FIB				300mm
FEI	1265	DUAL BEAM FIB	X			300mm
FEI	EXPIDA 1255S	MANUAL LOAD, NO STEM, NGSEM COL	X			300mm
FEI	G2 T20 U-TWIN	MICROSCOPE	X			300mm
HITACHI	M712E	ETCHER		X		300mm
HITACHI HTA	S9380-II	CD SEM	X			300mm
HITACHI HTA	S9380	CD SEM	X			300mm
INFRARED LABS	IREM1	NEAR INFRARED EMISSIONS MICROSCOPE	X			300mm
KOKUSAI	LCT / QUIXACE I	FURNACE		X		300mm
KOKUSAI	ZESTONE III (B)	FURNACE		X		300mm
KOKUSAI	ZESTONE-3	FURNACE		X		300mm
KOKUSAI	ZESTONE V	FURNACE		X		300mm
JORDAN VALLEY / BEDE	FAB 300	EPI - XRD THICKNESS/STRAIN	X			300mm

KLA TENCOR CORPORATION	5341	CD OPTICAL MEASURE	X		300mm
KLA TENCOR CORPORATION	7341	CD OPTICAL MEASUREMENT (NOT XP)		X	300mm
KLA TENCOR CORPORATION	AIT UV	DARKFIELD INSPECTION	X		300mm
KLA TENCOR CORPORATION	AIT UV+	DARKFIELD PATTERN INSPECTION	X		300mm
KLA TENCOR CORPORATION	AIT UV++	DARKFIELD PATTERN INSPECTION	X		300mm
KLA TENCOR CORPORATION	AIT-XP PLUS	PATTERNED WAFER INSPECTION, DARK FIELD	X		300mm
KLA TENCOR CORPORATION	ARCHER-10XT+	OVERLAY REGISTRATION		X	300mm
KLA TENCOR CORPORATION	ASET-F5	THICKNESS MEASURE		X	300mm
KLA TENCOR CORPORATION	EAIM+	OVERLAY REGISTRATION	X		300mm
KLA TENCOR CORPORATION	INS3300	REVIEW STATION, OPTICAL DEFECT	X		300mm
KLA TENCOR CORPORATION	SCD-XT	SCATTEROMETRY METROLOGY TOOL, NC	X		300mm
KLA TENCOR CORPORATION	SP1	BARE WAFER INSPECTION		X	300mm
KRATOS	SPE3000A	X-RAY PHOTOELECTRON SPECTROMETER	X		300mm
LINTEC OF AMERICA INC	RAD3010F12	DETAPE FOR BACKSIDE GRIND, DP	X		300mm
LK TECHNOLOGIES	TDS	THERMAL DISTORTION SPECTROMETER	X		300mm
NANOMETRICS INC	QS3300	DOPANT CONCENTRATION	X		300mm
NANOMETRICS INC	NANOSPEC 8300X	THIN FILMS MEASURING SYSTEM	X		300mm
NIKON PRECISION INC	9M(SF100)	EXPOSURE, PDPI, CU	X		300mm
NIKON PRECISION INC	S204	248NM (0.68NA) SCANNER	X		300mm
NIKON PRECISION INC	S205	248NM (0.75NA) SCANNER	X		300mm
NIKON PRECISION INC	S208	248NM (.82 NA) SCANNER	X		300mm
NIKON PRECISION INC	S307E	193NM (0.85NA) SCANNER - ARF	X		300mm
NIKON PRECISION INC	S610	193NM (1.3NA) IMMERSION SCANNER		X	300mm
NOVELLUS SYSTEMS INC	SINGLE ALTUS	W DEP	X		300mm
OERLIKON USA	STARLINE 300	BACKSIDE METAL TOOL, C4	X		300mm
RUDOLPH	3DI 8000	C4 BUMP INSPECTION	X		300mm
RUDOLPH	METAPULSE 300	FILM THICKNESS		X	300mm
RUDOLPH	S-300	THICKNESS MEASURE		X	300mm
THERMO FI LTD	ELEMENT 2	ICPMS	X		300mm
TOKYO ELECTRON LTD / TEL	LITHIUS	TRACK, BARC		X	300mm
TOKYO ELECTRON LTD / TEL	LITHIUS	SINGLE BLOCK	X		300mm
TOKYO ELECTRON LTD / TEL	LITHIUS i+	DUAL BLOCK	X		300mm
TOKYO ELECTRON LTD / TEL	PR300Z	BACKEND CLEAN		X	300mm
TOKYO ELECTRON LTD / TEL	PR300Z	BACKEND CLEAN, CU		X	300mm
TOKYO ELECTRON LTD / TEL	SCCM	ETCHER (2 SCCM CHAMBERS)	X		300mm
TOKYO ELECTRON LTD / TEL	TELIUS	ETCHER (2 DRM CHAMBERS)	X		300mm
TOKYO ELECTRON LTD / TEL	TELIUS SCCM	ETCHER (2 SCCM CHAMBERS)	X		300mm
ULTRATECH INCORPORATED	SATURN SPEC 300	GHI EXPOSE TOOL, C4	X		300mm
ULTRATECH INCORPORATED	STARLINE 300	BACKSIDE METAL TOOL, C4	X		300mm
ULTRATECH INCORPORATED	UNITY AP300	C4 EXPOSE		X	300mm
VARIAN	VIISTA 810HP	MEDIUM CURRENT INPLANTER		X	300mm
VARIAN	VIISTA 810	MEDIUM CURRENT INPLANTER		X	300mm
ZYGO	CP 300I	NEW VIEW 5000	X		300mm